

RABIN & BERDO, P.C.

Specializing in Patent, Trademark
And Copyright Law

Steven M. Rabin Robert H. Berdo, Jr. Phillip G. Avruch Allen Wood Qixia Zhang, Pat. Agent (China) Suite 500, 1101 14th Street, N.W. Washington, D.C. 20005 Tel.: (202) 371-8976 Fax: (202) 408-0924 E-Mail: firm@rabinchamp.com

January 28, 2004

In Affiliation with
Weiss, Moy & Harris, PC
having offices in Arizona and Nevada,
and in Washington, DC with
Rabin & Berdo, PC

Attorney Reference: MAE 306



Mail Stop Patent Application

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

Re: New Patent Application of: Kazuhide ABE

Title: METHOD OF FORMING BURIED WIRING IN SEMICONDUCTOR

DEVICE

Sir:

Please find attached hereto an application for patent which includes:

[x] Specification, Claims and Abstract (15 Pages)

[x] 2 Sheets of Formal Drawings (Fig. 1A through Fig. 2F)

[x] Inventor's Declaration and Power of Attorney (3 Pages)

[x] Assignment document with cover page (2 Pages)

[x] Claim for priority and Priority document

[x] Information Disclosure Statement, Form PTO-1449, and copies of 2 cited

references

[x] Form PTO-2038 (1 Page)

[x] Fee (see formula below)

TOTAL FEES FOR THE ABOVE APPLICATION	\$ 810.00
Recording Fee \$40.	\$40.00
Multiple Dependent Claims \$290/145	\$0.00
Number of independent claims: 2 in excess of 3: 0 times \$86/43	\$0.00
Total number of claims: 15 in excess of 20: 0 times \$18/9	\$0.00
Basic Fee \$770/385 Additional Fees:	\$770.00

In the event there is attached hereto no credit card form PTO-2038 or check, or there is an insufficient amount, please charge the fee to our Account No. 18-0002 and notify us accordingly.

The rights of priority are claimed under 35 USC §119 of Japanese Application No. 2003-271803, filed July 8, 2003.

January 28, 2004	
	<u>Bartariji da pang</u>
RHB:tz	

Robert H. Berdo, Jr. (Reg. No. 38,075) (Customer No. 23995)

Respectfully submitted.